

Notice of References Cited	Application/Control No. 10/626,767		Applicant(s)/Patent Under Reexamination PARK ET AL.	
	Examiner David Y. Chung		Art Unit 2871	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,929,958	07-1999	Ohta et al.	349/141
*	B	US-5,034,339	07-1991	Tanaka et al.	438/158
*	C	US-5,034,340	07-1991	Tanaka et al.	438/158
*	D	US-5,045,485	09-1991	Tanaka et al.	438/158
*	E	US-5,065,202	11-1991	Tanaka et al.	257/59
*	F	US-4,960,719	10-1990	Tanaka et al.	438/158
*	G	US-5,703,668	12-1997	Shin, Woo-Sup	349/110
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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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